



AF
JRW

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2814

PATENT

Customer No. 22,852
Attorney Docket No. 04329.1952-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshitaka TSUNASHIMA et al.) Group Art Unit: 2814
Application No.: 09/688,989) Examiner: Shrinivas H. RAO
Filed: October 17, 2000) Confirmation No.: 2408
For: SEMICONDUCTOR DEVICE AND)
METHOD OF MANUFACTURING)
THE SAME)

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed December 21, 2005, the period for response extends through March 21, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.

Entered w/ RCE
JMB
5/23/06